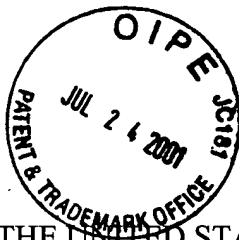


A13

862.C2168



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Unassigned
SEIJI TAKEUCHI, ET AL.	)	
	:	Group Art Unit: 3652
Appln. No.: 09/819,670	)	
	:	
Filed: March 29, 2001	)	
	:	
For: STOCKER, EXPOSURE	)	July 24, 2001
APPARATUS, DEVICE	:	
MANUFACTURING METHOD,	)	
SEMICONDUCTOR	:	
MANUFACTURING	)	
FACTORY, AND EXPOSURE	:	
APPARATUS MAINTENANCE	)	
METHOD	:	

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Okabe article and Japanese Patent Document 5-66733 are discussed on page 2 of the subject application.

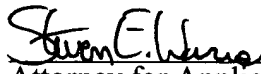
The U.S. Patents correspond to the cited Japanese document.

Applicants request that the Examiner consider the cited information and return an initialed copy of the enclosed PTO-1449 Form indicating that such information has been considered.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

  
\_\_\_\_\_  
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SEW/lmj